



SCOPE OF ACCREDITATION

Laboratory Name:

S.V. NANOMETROLOGY PVT. LTD., PLOT NO. E-3, SANJAY COLONY,

SEC-23, FARIDABAD, HARYANA, INDIA

Accreditation Standard

ISO/IEC 17025:2017

Certificate Number

CC-2472

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Validity

11/02/2025 to 10/02/2029

S.No	Discipline / Group	Measurand or Reference Material/Type of instrument or material to be calibrated or measured / Quantity Measured /Instrument	Calibration or Measurement Method or procedure	Measurement range and additional parameters where applicable(Range and Frequency)	* Calibration and Measurement Capability(CMC)(±)
		7/0	Permanent Facility	100	
1	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Reference Sphere / Steel Ball	Using Laser Measuring System with LMM By Comparison Method	Upto 100 mm	0.05 μm
2	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit L.C: 0.0005 mm / 0.001 mm	Using Plain Plug/ Ring Gauge (Type A,B,C) By Comparison Method	+/- 0.04 mm	0.25 μm
3	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit (Digital) L.C: 0.0001 mm	Using Plain Plug / Ring Gauge (Type A,B,C) By Comparison Method	± 0.1 mm	0.96 μm
4	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit (Digital/Dial) L.C: 0.002 mm	Using Plain Plug / Ring Gauge (Type A,B,C) By Comparison Method	± 0.08 mm	1.41 μm
5	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Gauge (Angle or Error in Angle)	Using Sine Bar, Gauge Block, Master Cylinder & 2D height Gauge By Comparison Method		1.1 sec
6	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Gauge(Error in Angle)	Using CMM By Comparison Method	0° to 90° to 0°	7.35 sec





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7	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm		
8	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate (Squareness)	Using CMM By Comparison Method	Upto 500 mm	3.6 μm		
9	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Flatness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm		
10	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Flatness)	Using CMM By Comparison Method	Upto 500 mm	3.6 μm		
11	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Parallelism)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm		
12	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Parallelism)	Using CMM (By Comparison Method)	Upto 500 mm	3.6 μm		





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13	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bench Centre (Co- axiality)	Using Standard Mandrels & Lever Type Dial Gauge By Comparison Method	Upto 1000 mm	4.4 μm
14	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bench Centre (Parallelism)	Using Standard Mandrels & Lever Type Dial Gauge By Comparison Method	0 to 1000 mm	4.4 μm
15	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bevel Angle Protector (Digital / Manual) L.C. 0.1 min / 5 min	Using Standard Angle Gauge By Comparison Method	0° to 180° to 0°	0.3 min
16	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bevel Angle Protector (Digital / Manual) L.C: 0.1 min / 5 min	Using CMM By Comparison Method	0° to 180° to 0°	1.5 s
17	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Block Squares (L.C: 0.001 μm) (Flatness)	Using Cylindrical Square & electronic Probe (By Comparison Method)	Upto 450 mm	3.21 μm
18	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Block Squares (Squareness) L.C: 0.001 µm	Using Cylindrical Squares & Electronic probe(By Comparison Method)	Upto 450 mm	3.21 μm





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19	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bore Gauge (2 Point) L.C.: 0.001 mm	Using Dial Calibrator Tester/ Gauge Blocks By Comparison Method	Upto 2 mm	0.7 μm
20	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bore Gauge (3 Point) L.C.: 0.001 mm	Using Master Ring Gauge By Comparison Method	Upto 160 mm	0.9 μm
21	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Flatness)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm
22	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Flatness)	Using CMM (By Comparison Method)	Upto 400 mm	3.6 μm
23	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Parallelism)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm
24	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Parallelism)	Using CMM By Comparison Method	Upto 500 mm	3.6 μm/m





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25	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Squareness)	Using CMM By Comparison Method	Upto 400 mm	3.6 μm
26	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Squareness)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm
27	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Clinometers / Inclinometrs L.C.: 1 min	Using Sine Bar, Gauge Blocks By Comparison Method	0 ° to 360 °	35 s
28	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	CNC Machine Tools	Using Laser Measuring System By Comparison Method	0 to 10 m	(0.5+L/1000) µm, where (L is in mm)
29	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Coating Thickness Gauge L.C.: 0.0001 mm	Using Standard Foils. By Comparison Method	0.009 mm to 2 mm	0.5 μm
30	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Combination Set L.C: 30 min / 1°	Using Sine Bar / Gauge Block & Angle Gauges By Comparison Method	0° to 180 °	35 min





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31	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Comparator stand (Flatness)	Using Gauge Block , Optical Flat, Dial Gauge Spirit Level 10µm/m By Comparison Method	500 mm x 500 mm	2.0 μm
32	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cone (Angle)	Using CMM By Comparison Method	Upto 360 °	1.64 s
33	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/ Master Cylinder (Straightness)	Using CMM (By Comparison Method)	Upto 700 mm	4 μm
34	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/ Master Cylinder (Flatness)	Using CMM (By Comparison Method)	Upto 700 mm	4 μm
35	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/ Master Cylinder (Squareness)	Using CMM By Comparison Method	Upto 700 mm	4 μm
36	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Straightness)	Using Gauge Blocks, Lever Dial & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6 μm/m





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37	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Flatness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6 μm/m
38	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6 μm/m
39	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Depth Gauge/Depth Vernier L.C 0.001 mm	Using Gauge Blocks &Length Bars. (By Comparison Method)	Upto 500 mm	5.1 μm
40	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Depth/Inside Micro Checker (L.C0.001 mm)	Using 2 D Height Gauge with Laser Measuring System By Comparison Method	Upto 300 mm	1.8 μm
41	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Depth/Inside Micro Checker (L.C0.001mm)	Using Gauge Block & Electronic Probe. (By Comparison Method)	Upto 300 mm	0.82 μm
42	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Dial Gauge / Plunger Lever Type Dial L.C 0.001 mm	Using Dial Calibrator Tester/ Gauge Blocks (By Comparison Method)	Upto 25 mm	0.292 μm





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43	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Dial Snap Gauge L.C.: 0.001 mm	Using Gauge Blocks By Comparison Method	Upto 200 mm	1.0 μm
44	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Dial Thickness Gauge/ Flush Pin Gauge L.C 0.001 mm	Using Gauge Blocks (By Comparison Method)	0 to 25 mm	0.8 μm
45	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Dial/Digital Plunger (L.C 0.0001 mm)	Using Laser Measuring System (By Comparison Method)	Upto 25 mm	0.22 μm
46	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Digital / Dial External Micrometer (Flange Type/Ball Type/V- Type/Pointed Type) L.C.: 0.0001 mm	Using Gauge Blocks/ Setting Masters & Optical Flat.(By Comparison Method)	Upto 50 mm	0.2 μm
47	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Digital / Dial Plunger/ Lever Type Gauge L.C.: 0.0001 mm	Using LMM By Comparison Method	0 to 25 mm	0.14 μm
48	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Digital /Manual Type Depth Micrometer L.C. 0.001 mm	Using Gauge Blocks. (By Comparison Method)	Upto 300 mm	1.1 μm





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49	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Elongation Gauge (Thickness)	Using Digital Caliper (By Comparison Method)	14.7 mm to 81.0 mm	10.58 μm
50	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Elongation Gauge (Thickness)	Using Digital Caliper (By Comparison Method)	4.8 mm to 33.90 mm	10.58 μm
51	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Straightness)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm/m
52	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Straightness)	Using CMM (By Comparison Method)	Upto 500 mm	3.6 µm
53	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Parallelism)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm/m
54	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Parallelism)	Using CMM By Comparison Method	Upto 500 mm	3.6 μm/m





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55	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm/m
56	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Squareness)	Using CMM By Comparison Method	Upto 500 mm	3.6 μm
57	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Extensometer L.C. 0.001mm	Using Gauge Block & Electronic Probe. (By Comparison Method)	Upto 150 mm	0.4 μm
58	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Extensometer Calibrator/Micromet er Head L.C. 0.1µm	Using Gauge Block & Electronic Probe. (By Comparison Method)	Upto 50 mm	0.11 μm
59	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	External Micrometer L.C 0.001 mm	Using Gauge Blocks ,optical flat & Length Bars. (By Comparison Method)	300 mm to 500 mm	1.55 μm
60	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	External Micrometer L.C 0.01 mm	Using Length Bar. (By Comparison Method)	500 mm to 1500 mm	4.24 μm





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61	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	External Micrometer L.C 0.001 mm	Using Gauge Block, Length Bar & Optical Flat. (By Comparison Method)	100 mm to 300 mm	1.30 μm
62	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	External Micrometer Digital/Dial L.C.: 0.001 mm	Using Gauge Blocks & Optical Flat By Comparison Method	0 to 100 mm	1.2 μm
63	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Filler Gauge (Thickness)	Using Digital Micrometer (By Comparison Method)	0.01 mm to 10.0 mm	1.4 μm
64	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Height Gauge L.C-0.01 mm	Gauge Blocks / Length Bar ,Electronic Probe & Surface Plate. (By Comparison Method)	Upto 1500 mm	6.52 μm
65	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Inside Dial Caliper L C.: 0.010 mm	Using Caliper Checker By Comparison Method	5 mm to 95 mm	8.0 μm
66	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Internal Micrometer L.C 0.001 mm	Using Caliper Checker , Gauge Blocks & Optical Flat. (By Comparison Method)	5 mm to 50 mm	0.8 μm





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67	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Internal Micrometer L.C 0.001 mm	Using Gauge Blocks,Optical Flat,Lever Type Dial Gauge. (By Comparison Method)	50 mm to 600 mm	1.8 μm
68	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Length Standard - (i) Setting Rods	Using Gauge Block, Electronic Probe & Length Bar. (By Comparison Method)	500 mm to 1000 mm	3.9 μm
69	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Length Standard - Micrometer Setting Rods	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	0 to 300 mm	0.45 μm
70	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Length Standard - Setting Masters	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	0 to 300 mm	0.45 μm
71	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Length Standard - Micrometer Setting Rods.	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	0 to 1000 mm	1.3 μm
72	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Length Standard - Setting Masters	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	0 to 1000 mm	1.3 μm





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73	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Level Calibrator (Length Standard)	Using CMM By Comparison Method	0 to 500 mm	2.38 μm
74	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Lever Type Dial Gauge L.C 0.001 mm	Using Laser Measuring System (By Comparison Method)	0 to 1 mm	0.22 μm
75	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Measuring Scale L.C.: 0.5 mm	Using Scale Tape & Calibrator By Comparison Method	Upto 1000 mm	35 μm
76	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Measuring Tape/PI Tape/ Count Meter L.C: 0.1 mm	Using Scale & Tape Calibrator by Comparison Method	0 to 50 m	35 x(L/1000) μm, Where L is in mm
77	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Notch (Check Angle)	Using Vision Measuring Machine (By Comparison Method)	Upto 300 mm	5.8 s
78	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Notch (Length, Height, Width)	Using CMM By Comparison Method	Upto 500 mm	(2.5+L/250) μm , where (L is in mm)





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79	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Notch (Radius)	Using Vision Measuring Machine By Comparison Method	Up to 300 mm	2.31 μm
80	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Pitch Gauge-Flank Angle	Using Vision Measuring Machine (By Comparison Method)	Upto 60°	5.81 s
81	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Pitch Gauge-Pitch	Using VMM Machine (By Comparison Method)	0 to 7 mm	1.77 μm
82	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical , Pin Gauge (Diameter)	Using Gauge Blocks & Electronic Probe by Comparison Method	0.01 mm to 25 mm	0.22 μm
83	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical Setting Masters (Diameter, Variation in diameter, Runout)	Using Gauge Block & Electronic Probe by Comparison Method	0.1 mm to 100 mm	0.25 μm
84	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical Setting Masters (Parallelism)	Using Gauge Block & Electronic Probe By Comparison Method	0.1 to 100 mm	0.25 μm





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85	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical, Plug Gauge (Diameter)	Using Gauge Blocks & Electronic Probe, LMM by Comparison Method	Upto 100 mm	0.25 μm			
86	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Measuring Prism (Error between angles of adjacent faces , Cumulative Error between Faces)	Using Gauge Blocks & Electronic Probe (By Comparison Method)	Upto 100 mm	0.7 μm			
87	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Pin Gauge/ wires (Diameter)	Using Gauge Blocks & Electronic Probe / LMM (By Comparison Method)	0.01 mm to 25 mm	0.25 μm			
88	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge (Diameter)	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	Upto 500 mm	1.3 μm			
89	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge /Setting Masters.	Using CMM By Comparison Method	100 mm to 400 mm	(1.5+L/350) μm (where L is in mm)			





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90	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge/ Cylindrical Pins / Measuring Prism / Wires /Setting Masters. (Diameter, Variation in diameter, Runout)	Using Laser Measuring System (By Comparison Method)	0.10 mm to 100 mm	0.22 μm
91	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge/ Cylindrical Pins / Measuring Prism / Wires /Setting Masters. (Diameter, Variation in diameter, Runout)	Using CMM By Comparison Method	0.1 mm to 100 mm	(1.5+L/350) μm, (where L is in mm)
92	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge/ Cylindrical Pins / Measuring Prism / Wires /Setting Masters. (Parallelism)	Using CMM By Comparison Method	0.1 mm to 100 mm	(1.5+L/350) μm, Where L is in mm.
93	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge/ Setting Masters (Diameter, Variation in diameter, Runout/parallelism)	Using Gauge Blocks & Electronic Probe By Comparison Method	100 mm to 500 mm	1.3 μm
94	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Cylindrical- Plug Gauge/Setting Masters.	Using Laser Measuring System with LMM By Comparison Method	100 mm to 400 mm	0.22 μm





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95	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Ring Gauge (Diameter at four positions ,Roundness)	Using Gauge Block & Electronic Probe, LMM by Comparison Method	2 mm to 100 mm	0.32 μm
96	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Ring Gauge (Diameter at four positions ,Roundness)	Using CMM By Comparison Method	2 mm to 500 mm	4.0 μm
97	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Ring Gauge (Diameter at four positions, Roundness)	Using Gauge Block & Electronic Probe ,LMM by Comparison Method	100 mm to 400 mm	1.68 μm
98	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Ring Gauge (Diameter at four positions, Roundness)	Using Laser Measuring System with LMM By Comparison Method	2 mm to 400 mm	0.22 μm/m
99	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Snap Gauge (Gap Size, Parallelism)	Using Gauge Blocks, LMM by Comparison Method	200 mm to 400 mm	1.26 μm
100	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Snap Gauge (Gap Size, Parallelism)	Using Gauge Blocks, LMM by Comparison Method	Upto 200 mm	1.26 μm





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101	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Snap Gauge (Gap Size, Parallelism)	Using CMM by Comparison Method	Upto 500 mm	4.0 μm		
102	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Taper Plug Gauge (Angle)	Using Sine Bar, Gauge Blocks, Standard Pins & Micrometer by Comparison Method	0 ° to 180 °	1.5 s		
103	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Taper Plug Gauge (Angle)	Using CMM by Comparison Method	0 ° to 180 °	1.76 s		
104	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain Taper Ring Gauge (Angle)	Using CMM by Comparison Method	0 ° to 180 °	1.65 s		
105	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Cone Angle)	Using Gauge Blocks ,Sine Centre & Dial Indicator. by Comparison Method	0 ° to 45°	1.1 s		
106	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Cone Angle)	Using CMM by Comparison Method	Upto 500 mm	1.71 s		





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107	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Length)	Using CMM by Comparison Method	0 to 500 mm	(1.5+L/500) μm, where (L is in mm)
108	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Straightness)	Using CMM by Comparison Method	0 to 500 mm	(1.5+L/500) μm, where (L is in mm)
109	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Total Run out)	Using CMM by Comparison Method	0 to 500 mm	(1.5+L/500) μm, where (L is in mm)
110	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Variation Of Diameter)	Using CMM by Comparison Method	Upto 500 mm	(1.5 + L/500) μm, where L is in mm
111	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Plain/Taper Mandrel (Variation of Diameter, Total Run out, Straightness, Length)	Using Gauge Blocks, Sine Centre & Electronic Probe by Comparison Method	Upto 500 mm	1.21 μm
112	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Radius Gauges / Radius Chart (concave and convex profiles) (Radius)	Using Profile Projector, Vision Measuring Machine by Comparison Method	0.05 mm to 300 mm	1.4 μm





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113	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Radius Gauges / Radius Chart (concave and convex profiles), (Radius)	Using CMM by Comparison Method	Upto 400 mm	(1.5+L/500) µm, where (L is in mm)			
114	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Radius gauges, Radius chart, Welding Fillet Gauge, Angle, Profile Templates, Vickers/Knoop/ Rockwell Diamond Cone Indenter, Part Drafting / Weld/ Hi- Lo gauge, bridge cam gauge /Traverse of cupping mechanical	Using Vision Measuring Machine by Comparison Method	Upto 300 mm	0.3 μm			
115	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Raiser Block (Mean height of raiser blocks)	Using Gauge Block & Electronic Probe by Comparison Method	Upto 300 mm	0.8 μm			
116	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Receiver Gauge/ C.D Gauge/ Jig Fixtures/ Width Gauge/Limit Gauge/Nozzle/Hegm ann gauge/Weld Fillet Gauge/ Straightness / Roundness/Referenc e Discs/ Concentricity Gauge/ Components 3D. Vickers/Knoop	Using CMM by Comparison Method	Upto 500 mm	2.97 μm			





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117	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Angle)	Using Gauge Blocks & Electronic Probe by Comparison Method	Upto 90°	0.3 s
118	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Angle)	Using CMM by Comparison Method	Upto 90°	1.76 s
119	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Center Distance)	Using CMM by Comparison Method	Upto 500 mm	3.06 μm
120	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Center Distance)	Using Gauge Blocks & Electronic Probe By Comparison Method	Upto 500 mm to	0.76 μm
121	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Flatness)	Using CMM by Comparison Method	Upto 500 mm	3.06 μm
122	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Flatness)	Using Gauge Block & Electronic Probe by Comparison Method	Upto 500 mm to	0.76 μm





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123	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Parallelism)	Using Gauge Block & Electronic Probe by Comparison Method	Upto 500 to	0.76 μm
124	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Bar (Parallelism)	Using CMM by Comparison Method	Upto 500 mm	3.06 µm
125	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Center distance)	Using Gauge Blocks & Electronic Probe by Comparison Method	Upto 500 mm	0.76 μm
126	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Center Distance)	Using CMM by Comparison Method	Upto 500 mm	2.44 μm
127	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Flatness)	Using Gauge Block & Electronic Probe.by Comparison Method	Upto 500 mm	0.76 μm
128	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Flatness)	Using CMM by Comparison Method	Upto 500 mm	2.44 μm





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129	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Parallelism)	Using Gauge Block & Electronic Probe by Comparison Method)	Upto 500 mm	0.76 μm
130	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Center (Parallelism)	Using CMM by Comparison Method	Upto 500 mm	2.44 μm
131	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Centre (Angle)	Using Gauge Block & Electronic Probe By Comparison Method	Upto 90°	0.3 s
132	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Sine Centre (Angle)	Using CMM by Comparison Method	Upto 90°	1.67 s
133	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Slip Gauge Accessories (Flatness, Parallelism)	Using Gauge Block, Electronic Probe & Optical Flat by Comparison Method	Upto 300 mm	1.4 μm
134	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Plug Gauge (Diameter over Pins)	Using Standard Pin ,Floating Carriage by Comparison Method	2 mm to 100 mm	0.9 μm





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135	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Plug Gauge (Diameter Over Pins)	Using standard Pins, LMM & Gauge Blocks by Comparison Method	5 mm to 300 mm	1.0 μm
136	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Plug Gauge (Diameter Over Pins)	Using CMM by Comparison Method	Upto 400 mm	(1.5+L/500) μm, where (L is in mm)
137	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Ring Gauge (Diameter over Pins)	Using Standard Pins & Gauge Blocks (By Comparison Method)	5 to 100 mm	0.41 μm
138	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Ring Gauge (Diameter Between Pins)	Using standard Pins, LMM & Gauge Blocks. (By Comparison Method)	5 mm to 300 mm	1.0 μm
139	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Spline Ring Gauge (Diameter Between pins)	Using CMM, Standard Pins. (By Comparison Method)	Upto 400 mm	(1.5+L/500) μm, where (L is in mm)
140	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Standard Foil Set (Thickness)	Using Gauge Blocks & Electronic Probe by Comparison Method	0.01 mm to 10 mm	0.5 μm





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141	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Straight Edge (Parallelism)	Using Level & Dial Gauge by Comparison Method	Upto 2000 mm	(2.2SQRT(L/100)) μm, (where L is in mm)
142	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Straight Edge (Parallelism)	Using CMM by Comparison Method	Upto 600 mm	3.06 μm
143	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Straight Edge (Straightness)	Using Level & Dial Gauge by Comparison Method	Upto 2000 mm	(2.2SQRT(L/100)) μm ,(where L is in mm)
144	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Straight Edge (Straightness)	Using CMM by Comparison Method	Upto 600 mm	3.06 μm
145	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Surface Plate (Flatness)	Using Precision Level (0.001 mm/m) by Comparison Method	6000 mm x 2000 mm	(1.3 SQRT(L+W/100)) µm, (where L & W is in mm)
146	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Test Sieve (Aperture size)	Using Profile projector/ Vision Measuring Machine By Comparison Method	0.02 mm to 4 mm	3.12 μm





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147	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Test Sieve (Aperture size)	Using Digital Caliper by Comparison Method	4 mm to 100 mm	7.6 μm
148	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Pitch Micrometer (Error in micrometer screw) L.C.: 0.001 mm	Using Standard Wear Check Plug by Comparison Method	0.7 mm to 2.5 mm	1.97 μm
149	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Plug Gauge/ WCP (Pitch Diameter)	Using FCDMM & Standard Wires by Comparison Method	1 mm to 100 mm	0.91 μm
150	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Plug Gauge/ WCP (Plain / Taper type) (Major Diameter)	Using FCDMM, Cylinder Setting Master by Comparison Method	1 mm to 100 mm	1.0 μm
151	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Plug Gauge/ WCP (Plain / Taper type) (Minor Diameter)	Using FCDMM & Prisms by Comparison Method	1 mm to 100 mm	0.9 μm
152	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Plug Gauge/ WCP (Plain/Taper) (Effective Dia.)	Using LMM, Cylinder Setting Master/Standard Wires by Comparison Method	100 mm to 400 mm	1.3 μm





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153	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Plug Gauge/ WCP(Plain/Taper) (Effective Dia.)	Using LMM, Cylinder Setting Master/Standard Wires by Comparison Method	1 mm to 100 mm	0.51 μm		
154	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Thread Ring Gauge / Taper Thread Ring Gauge (Minor Diameter, Effective Diameter)	Using LMM Machine, Master Setting Ring by Comparison Method	2 mm to 100 mm	0.51 μm		
155	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Linear) L.C: 0.001 mm	Using Glass Scale by Comparison Method	Upto 100 mm	0.8 μm		
156	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Linear) L.C: 0.001 mm	Using Laser Measuring System by Comparison Method	Upto 1000 mm	(0.21xL/1000) µm; Where L is in mm		
157	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Magnification)	Using Glass Scale by Comparison Method	Upto 180X	0.06 %		
158	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Parallelism)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m		





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159	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Parallelism)	Using CMM by Comparison Method	0 to 500 mm	3.6 μm/m
160	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Squareness)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m
161	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Squareness)	Using CMM by Comparison Method	0 to 500 mm	3.6 μm/m
162	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Straightness)	Using CMM by Comparison Method	0 to 500 mm	3.6 μm/m
163	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square, (Straightness)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m
164	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Angle "V")	Using CMM by Comparison Method	Upto 90°	2 s





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165	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Angle of "V")	Using Angle Gauges & Electronic Probe by Comparison Method	Upto 90°	1.5 s
166	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Flatness)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm
167	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Parallelism)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	Upto 150 mm	1.82 μm
168	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Parallelism)	Using CMM by Comparison Method	Upto 200 mm	1.82 μm
169	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Squareness)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm
170	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Symmetry)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm





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171	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V-Block (Flatness)	Using CMM By Comparison Method	Upto 200 mm	1.81 μm		
172	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V-Block (Squareness)	Using CMM By Comparison Method	Upto 200 mm	1.81 μm		
173	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V-Block (Symmetry)	Using CMM By Comparison Method	Upto 200 mm	1.81 μm		
174	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Vernier Caliper L.C 0.01 mm (Error- External Jaws, Error- Internal Jaws, Error- Depth, Parallelism of Ext Jaws, Parallelism of Int. Jaws)	Using Caliper Checker by Comparison Method	Upto 300 mm	5.1 μm		
175	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Vernier Caliper L.C: 0.01 mm (Error- External Jaws, Error- Internal Jaws, Error- Depth, Parallelism of Ext Jaws, Parallelism of Int. Jaws)	Using Length Bar & Gauge Blocks By Comparison Method	Upto 1000 mm	6.0 μm		
176	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Vernier Caliper L.C: 0.01 mm	Gauge Blocks & Length Bars by Comparison Method	0 to 2000 mm	13.0 μm		





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177	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	3D Co - ordinate Measuring Machine (Length Measuring Error) L.C.: 0.0001 mm	Using Laser Measuring system & Step gauge By Comparison Method	Up to 2000 mm	(0.9381 + sqrt(L)/2000) µm, where L is in mm
178	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	3D Co-ordinate Measuring Machine L.C0.0001mm (Probing Error, Length Measuring Error)	Using Step gauge, Gauge Blocks, Test Sphere (By Comparison Method)	Upto 1 m x 1 m x 1 m	6 x L μm, (where L is in m)
179	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Angular Graticule (Angle) L.C.: 1 sec	Using Profile Projector/Vision Measuring Machine By Comparison Method	0 ° to 360 °	5.8 arc of sec
180	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Ball Bar System -Ball Bar Calibrator. (Center Distance)	Using CMM By Comparison Method	Upto 300 mm	(1.5+ L/300) µm, where (L is in mm)
181	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Ball Bar System, Ball Bar Transducer. (Linear displacement)	Using LMM & ULM By Comparison Method	Travel ± 1.0 mm (Range u	0.98 μm
182	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Caliper Checker (Length)	Using 2D Height Gauge with Laser Measuring System By Comparison Method	0 to 1000 mm	0.63 μm/m
183	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Caliper Checker (Length)	Using Length Bar & Electronic Probe By Comparison Method	0 to 1000 mm	2.9 μm
184	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Caliper Checker (Length)	Using CMM by Comparison Method	Up to 600 mm	3.0 μm





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185	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Caliper Checker (Length)	Using Gauge Block & Electronic Probe By Comparison Method	Upto 600 mm	1.8 µm
186	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Dial Gauge / Plunger/ Lever Type (L.C: 0.0005 mm) (Error in Band)	Using LMM by Comparison Method	Up to ± 0.025 mm	0.09 μm
187	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Digital / Dial Calibration Tester (L.C: 0.0002mm) (Drum Error)	Using Laser Measuring System/Optical Flat (By Comparison Method)	0 to 25 mm	0.08 μm
188	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Digital / Dial Calibrator Tester L.C0.0001 mm (Drum Error)	Using Gauge Blocks. (By Comparison Method)	Upto 25 mm	0.17 μm
189	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Electronic Level/Precision Level/Spirit Level (Sensitivity: 0.001/0.01 mm/m) (Error, Bubble Measuring Error, Flatness of Base)	Using Level Calibrator By Comparison Method	Up to 5 mm/m	1.2 μm/m
190	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Electronic Probe L.C 0.01 µm / 0.1 µm (Error in Length Measurement)	Using Gauge Block. (By Comparison Method)	Upto 25 mm	0.12 μm
191	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Electronic Probe L.C 0.01 µm / 0.1 µm (Error in Length Measurement)	Using Laser Measuring System (By Comparison Method)	Upto 25 mm	0.22 μm/m





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192	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Floating Carriage DMM L.C 0.1 µm Straightness/ Concentricity / Micrometer Travel / Flatness of Measuring Faces. (Micrometer Head Error, Alignment of centres to base, Parallelism of micrometer face)	Using Gauge Blocks / Electronic Probe / Cylindrical Setting Master By Comparison Method	0 to 175 mm	0.8 μm
193	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Steel) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator (By Comparison Method)	10 mm to 25 mm	0.11 μm
194	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Carbide) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator by Comparison Method	0.5 mm to 10 mm	0.08 μm
195	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Carbide) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator by Comparison Method	10 mm to 25 mm	0.083 μm
196	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Carbide) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator by Comparison Method	25 mm to 50 mm	0.095 μm
197	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Carbide) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator by Comparison Method	50 mm to 100 mm	0.2 μm





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198	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Steel) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator (By Comparison Method)	0.5 mm to 10 mm	0.09 μm			
199	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Steel) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator (By Comparison Method)	25 mm to 50 mm	0.15 μm			
200	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Gauge Blocks (Steel) Grade-K/ 0/1/ 2 (Gauge Length, Variation in Length, Flatness)	Using Gauge Blocks & Gauge Block Comparator (By Comparison Method)	50 mm to 100 mm	0.20 μm			
201	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Glass Scales / Glass Grid (Error between graduation lines over entire length)	Using Laser Measuring System with UMM by comparison method	0 to 400 mm	0.35 μm/m			
202	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Height Gauge (Digital Electronic Comparator L.C 0.0001 mm) (Measuring Error along working length)	Using Gauge Block & Electronic Probe/Caliper Checker. (By Comparison Method)	Upto 600 mm	2.0 μm			
203	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Height Gauge / 2 D Height Gauge L.C : 0.0001 mm (Linear Error/ Squareness)	Using Laser Measuring System (By Comparison Method)	Up to 600 mm	0.22 μm/m			
204	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Height Micrometer / Check Master Depth/Inside Micro- Checker L.C. 0.001 mm (Length)	Using Gauge Blocks & Electronic Probe. (By Comparison Method)	Upto 600 mm	1.67 μm			





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205	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01 µm	Using Laser Measuring System by Comparison Method	Upto 5000 mm	(0.09+(L/10) μm; where L is in m
206	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01µm	Using Gauge Blocks by Comparison Method	Upto 100 mm	0.12 μm
207	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01µm	Using Gauge Blocks by Comparison Method	Upto 500 mm	0.12 +(L/10) μm; where L is in m
208	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length Standard - Length Bar (Long Gauge Blocks)	Using Gauge Blocks & Electronic Probe (By Comparison Method)	Upto 1000 mm	1.3 μm
209	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length Standard - Length Bar (Long Gauge Blocks)	Using 2D Height Gauge with Laser Measuring System by comparison method	Upto 1000 mm	0.22 μm/m
210	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length Standard - Length Bar (Long Gauge Blocks)	Using Gauge Blocks & Electronic Probe By Comparison Method	Upto 300 mm	0.45 μm
211	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length Standard- Setting Masters	Using 2D Height Gauge with Laser Measuring System(By Comparison Method)	0 to 1000 mm	0.22 μm/m
212	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Level Calibrator (Length)	Using 2D Height Gauge & Gauge Blocks By Comparison Method	Upto 500 mm	0.91 μm





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213	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Micrometer Head (Linear Error, Flatness of Anvils) L.C.: 0.0001 mm & coarser	Using Laser Measuring System/Optical Flat By Comparison Method	0 to 25 mm	0. 1 2 μm
214	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Optical Flat Type A (Flatness)	Using Monochromatic Light,Master Optical Flat. (By Comparison Method)	Upto 100 mm	0.084 μm
215	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Optical Parallel / Optics Flats Type B (Flatness of Both Faces)	Using Monochromatic light, Master Optical Flat (By Comparison Method)	Upto 45 mm	0.084 μm
216	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector - Magnification	Using Glass Scale / Gauge Blocks / Angle Gauges (By Comparison Method)	Upto 180x	0.06 %
217	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine Angular Scale L.C: 1 arc sec	Using Angle Gauges by Comparison Method	Upto 360 °	3.55 arc sec
218	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine X,Y Axis (Linear Scale: L.C. 0.001 mm)	Using Glass Scale By Comparison Method	Up to 400 mm	1.05 μm
219	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine(VMM) X,Y Axis (Linear Scale- L.C. 0.001 mm) (Linear Error)	Using Laser Measuring System By Comparison Method	Upto 1000 mm	0.62 μm/m





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220	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Scale Tape Calibrator (L.C.: 0.001 mm)	Using Gauge Blocks & Length Bar By comparison Method	Up to 1000 mm	11 μm/m
221	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Scale Tape Calibrator (L.C.: 0.001 mm)	Using Laser Measuring System By comparison Method	Upto 1000 mm	0.22 μm/m
222	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Step Checking Gauge	Using 3D Co- ordinate Measuring Machine By comparison Method	Upto 600 mm	4.0 μm
223	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Step Gauge	Using Length Bar & Electronic Probe.(By Comparison Method)	Upto 1000	3 μm
224	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Step Gauge	Using 2D Height Gauge with Laser Measuring System By Comparison Method	Upto 1000 mm	0.22 μm/m
225	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Step Gauge	Using Gauge Block & Electronic Probe.(By Comparison Method)	Upto 600 mm	1.5 μm
226	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Surface Roughness Tester (Portable) (L.C: 0.01 µm)	Using Surface Roughness master/ Optical Flat / Step Gauge using comparison method	Ra: 2 μm, Rmax: 15 μm	6.4 μm
227	MECHANICAL- DUROMETER	Rubber Hardness Calibrator	Using Weights by comparison method	0 to 100 Shore A	0.39 Shore A
228	MECHANICAL- DUROMETER	Rubber Hardness Calibrator	Using Weights by comparison method	0 to 100 Shore D	0.17 Shore D





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229	MECHANICAL- DUROMETER	Rubber Hardness Tester	Using Rubber Hardness Calibrator (By Comparison Method)	0 to 100 Shore D	0.52 Shore D
230	MECHANICAL- DUROMETER	Rubber Hardness Tester (Shore A)	Using Rubber Hardness Calibrator (By Comparison Method)	0 to 100 Shore A	0.93 Shore A





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		7/0	Site Facility	24. 100	
1	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit L.C: 0.0005 mm / 0.001 mm	Using Plain Plug/ Ring Gauge (Type A,B,C) By Comparison Method	+/- 0.04 mm	0.25 μm
2	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit (Digital) L.C: 0.0001 mm	Using Plain Plug / Ring Gauge (Type A,B,C) By Comparison Method	± 0.1 mm	0.96 μm
3	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Air Gauge Unit (Digital/Dial) L.C: 0.002 mm	Using Plain Plug / Ring Gauge (Type A,B,C) By Comparison Method	± 0.08 mm	1.41 μm
4	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm
5	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Flatness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm
6	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Angle Plate(Parallelism)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm





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7	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bench Centre (Co-axiality)	Using Standard Mandrels & Lever Type Dial Gauge By Comparison Method	Upto 1000 mm	4.4 μm
8	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Bench Centre (Parallelism)	Using Standard Mandrels & Lever Type Dial Gauge By Comparison Method	0 to 1000 mm	4.4 μm
9	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Flatness)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm
10	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Parallelism)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm
11	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Box Plate (Squareness)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm
12	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	CNC Machine Tools	Using Laser Measuring System By Comparison Method	0 to 10 m	(0.5+L/1000) μm, where (L is in mm)





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S.V. NANOMETROLOGY PVT. LTD., PLOT NO. E-3, SANJAY COLONY,

SEC-23, FARIDABAD, HARYANA, INDIA

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S.No	Discipline / Group	Measurand or Reference Material/Type of instrument or material to be calibrated or measured / Quantity Measured /Instrument	Calibration or Measurement Method or procedure	Measurement range and additional parameters where applicable(Range and Frequency)	* Calibration and Measurement Capability(CMC)(±)
13	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Straightness)	Using Gauge Blocks, Lever Dial & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6 μm/m
14	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Flatness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6 μm/m
15	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Cylindrical Square/Master Cylinder (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6 μm/m
16	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Straightness)	Using Gauge Blocks & Cylindrical Square. (By Comparison Method)	Upto 450 mm	6.0 μm/m
17	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Parallelism)	Using Gauge Blocks & Cylindrical Square(By Comparison Method)	Upto 450 mm	6.0 μm/m
18	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Engineer's Square (Squareness)	Using Gauge Blocks & Cylindrical Square By Comparison Method	Upto 450 mm	6.0 μm/m





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19	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Extensometer L.C. 0.001mm	Using Gauge Block & Electronic Probe. (By Comparison Method)	Upto 150 mm	0.4 μm
20	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Surface Plate (Flatness)	Using Precision Level (0.001 mm/m) by Comparison Method	6000 mm x 2000 mm	(1.3 SQRT(L+W/100)) µm, (where L & W is in mm)
21	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Linear) L.C: 0.001 mm	Using Glass Scale by Comparison Method	Upto 100 mm	0.8 μm
22	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Linear) L.C: 0.001 mm	Using Laser Measuring System by Comparison Method	Upto 1000 mm	(0.21xL/1000) μm; Where L is in mm
23	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tool Maker / Universal Measuring Microscope (Magnification)	Using Glass Scale by Comparison Method	Upto 180X	0.06 %
24	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Parallelism)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m





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25	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square (Squareness)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m
26	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	Tri Square, (Straightness)	Using Gauge Blocks & Cylindrical Square by Comparison Method	0 to 450 mm	6.0 μm/m
27	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Angle of "V")	Using Angle Gauges & Electronic Probe by Comparison Method	Upto 90°	1.5 s
28	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Flatness)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm
29	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Parallelism)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	Upto 150 mm	1.82 μm
30	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Squareness)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm





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31	MECHANICAL- DIMENSION (BASIC MEASURING INSTRUMENT, GAUGE ETC.)	V Block (Symmetry)	Using Gauge Block, Cylindrical Square, Mandrel & Electronic Probe By Comparison Method	0 to 150 mm	1.82 μm	
32	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	3D Co - ordinate Measuring Machine (Length Measuring Error) L.C.: 0.0001 mm	Using Laser Measuring system & Step gauge By Comparison Method	Up to 2000 mm	(0.9381 + sqrt(L)/2000) μm, where L is in mm	
33	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	3D Co-ordinate Measuring Machine L.C0.0001mm (Probing Error, Length Measuring Error)	Using Step gauge, Gauge Blocks, Test Sphere (By Comparison Method)	Upto 1 m x 1 m x 1 m	6 x L μm, (where L is in m)	
34	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Digital / Dial Calibration Tester (L.C: 0.0002mm) (Drum Error)	Using Laser Measuring System/Optical Flat (By Comparison Method)	0 to 25 mm	0.08 μm	
35	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Digital / Dial Calibrator Tester L.C0.0001 mm (Drum Error)	Using Gauge Blocks. (By Comparison Method)	Upto 25 mm	0.17 μm	
36	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Floating Carriage DMM L.C 0.1 µm Straightness/ Concentricity / Micrometer Travel / Flatness of Measuring Faces. (Micrometer Head Error, Alignment of centres to base, Parallelism of micrometer face)	Using Gauge Blocks / Electronic Probe / Cylindrical Setting Master By Comparison Method	0 to 175 mm	0.8 μm	





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37	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01 µm	Using Laser Measuring System by Comparison Method	Upto 5000 mm	(0.09+(L/10) μm; where L is in m		
38	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01µm	Using Gauge Blocks by Comparison Method	Upto 100 mm	0.12 μm		
39	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Length / Universal Measuring Machine (Length Measuring error over entire range) L.C.: 0.01µm	Using Gauge Blocks by Comparison Method	Upto 500 mm	0.12 +(L/10) μm; where L is in m		
40	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector - Magnification	Using Glass Scale / Gauge Blocks / Angle Gauges (By Comparison Method)	Upto 180x	0.06 %		
41	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine Angular Scale L.C: 1 arc sec	Using Angle Gauges by Comparison Method	Upto 360 °	3.55 arc sec		
42	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine X,Y Axis (Linear Scale: L.C. 0.001 mm)	Using Glass Scale By Comparison Method	Up to 400 mm	1.05 μm		
43	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Profile Projector / Vision Measuring Machine(VMM) X,Y Axis (Linear Scale- L.C. 0.001 mm) (Linear Error)	Using Laser Measuring System By Comparison Method	Upto 1000 mm	0.62 μm/m		





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44	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Roundness Tester / Radial / Axial /Straightness. (Roundness)	Using Gauge Blocks /Master Cylinder /Test sphere by Comparison Method)	300 mm x 350 mm	4.0 μm
45	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Scale Tape Calibrator (L.C.: 0.001 mm)	Using Gauge Blocks & Length Bar By comparison Method	Up to 1000 mm	11 μm/m
46	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Scale Tape Calibrator (L.C.: 0.001 mm)	Using Laser Measuring System By comparison Method	Upto 1000 mm	0.22 μm/m
47	MECHANICAL- DIMENSION (PRECISION INSTRUMENTS)	Surface Roughness Tester (Portable) (L.C: 0.01 µm)	Using Surface Roughness master/ Optical Flat / Step Gauge using comparison method	Ra: 2 μm, Rmax: 15 μm	6.4 μm

^{*} CMCs represent expanded uncertainties expressed at approximately the 95% level of confidence, using a coverage factor of k = 2.